



September 14, 2022

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Dear Dr. Li, Dr. Saito, Dr. Wei, Dr. Sadeghi, Dr. Hu, Dr. Seo, Dr. Nagano, Dr. Fursund, Dr. Chen, Dr. Chen and Dr. Sun,

This letter is a formal notification that the ACM Ethics and Plagiarism Committee of the ACM Publications Board has completed its investigation of the complaint against you for violating the [ACM Policy on Plagiarism, Misrepresentation, and Falsification](#) in two ACM-published papers. The papers are "Avatar digitization from a single image for real-time rendering" by Liwen Hu, Shunsuke Saito, Lingyu Wei, Koki Nagano, Jaewoo Seo, Jens Fursund, Iman Sadeghi, Carrie Sun, Yen-Chun Chen, and Hao Li published in the ACM Transactions on Graphics. 36, 6, Article 195 (December 2017), 14 pages, <https://doi.org/10.1145/3130800.31310887>; and "Pinscreen: creating performance-driven avatars in seconds," by Hao Li, Shunsuke Saito, Lingyu Wei, Iman Sadeghi, Liwen Hu, Jaewoo Seo, Koki Nagano, Jens Fursund, Yen-Chun Chen, and Stephen Chen, published in the ACM SIGGRAPH 2017 Real Time Live! (SIGGRAPH 2017). Association for Computing Machinery, New York, NY, USA, page 23, <https://doi.org/10.1145/3098333.3107546>. You are an author on one or both of the ACM's papers.

The Committee has reviewed the evidence gathered during the investigation and has found you guilty of violating the above referenced ACM Policy. Specifically, the Committee found that the presentation at SIGGRAPH 2017 Real Time Live! falsely presented pre-generated images as dynamically created. This fact should have been disclosed to the audience, but was not. This data falsification extended to the ACM Transaction on Graphics article. You knowingly participated in the preparations for either the SIGGRAPH 2017 Real Time Live! demonstration or the ACM Transactions on Graphics article. The above referenced Policy requires that "all authors understand that they will be held equally accountable for any issues relating to the correctness or integrity of the work, including any potential ethical violations."

As a result, the Committee has determined that your actions constitute a [Level V](#) violation. A Level V violation comes with the following penalties and required actions:

- You are expected to write a letter of apology to parties identified during the investigation, including an admission of wrongdoing to:

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- The two published articles in the ACM Digital Library will be retracted with a Notice of Retraction that will provide the reason for the retractions.
- You will be banned from serving in an official role for any ACM Publication for the next five years. These roles include reviewers, editors, conference program chairs, and serving on conference committees. This ban also applies to submitting to any ACM publication venue, including conferences, journals, magazines, and any other ACM Publications as defined in ACM's Policy.
- The case and evidence will be forwarded to the ACM Committee on Professional Ethics for further consideration as to whether your violation also constituted an [ACM CODE](#) violation, in addition to violating ACM's Publications Policies.

Please note that ACM does have [an official appeals process](#) in the event you feel that ACM's decision is incorrect and you have substantive evidence that contradicts ACM's finding. In such a case, you may file an official appeal to ACM's President, Yannis Ioannidis, at president@acm.org within 30 days from the date on this letter. If you decide to appeal this decision, you will need to provide tangible and credible evidence to ACM's President that directly disproves ACM's finding. Please note that simply disagreeing with the Committee's decision is not sufficient justification for an appeal. Without such evidence substantiating your request for an appeal, it is highly unlikely that ACM's decision would be overturned.

Sincerely,



Scott Delman, ACM Director of Publications

cc: Yannis Ioannidis, ACM President
Michael S. Kirkpatrick, Chair ACM Ethics & Plagiarism Committee
Eugene H. Spafford, Vice-Chair ACM Ethics & Plagiarism Committee
Barbara Ryan, Intellectual Property Rights Manager